



Research and Development Section
Indian Institute of Technology Guwahati
Guwahati-781039, Assam

Applications are invited for **Walk-in-interview** of the following post(s) for **Contractual recruitment** in the project entitled, "**Indian Nano electronics Users' Programme - Idea to Innovation (INUP-i2i)**" at **Centre for Nanotechnology, IIT Guwahati**.

Date: 31st July 2023 (Wednesday)

Time: 10:00 A.M

Venue: Conference Room, Centre for Nanotechnology, IIT Guwahati

Sl. No.	Project Staff Designation	Number of Vacancies	Pay Recommended (Rs.)	HRA Required (Rs.)	Medical Required (Rs.)	Total Amount (Rs.)	Duration of Appointment in months	Qualifications
1	SRF (DIRECT)	03	35000.00	Yes 6300.00	1250.00	42550.00	03	<p>Post Graduate in basic science or Graduate/Post Graduate in Professional Course selected through a process described through any one of the following:</p> <ol style="list-style-type: none">Scholars selected through National Eligibility Test-CSIR-UGC NET including Lectureship (Assistant Professors hip) and GATE.The selection process through National Level Examinations conducted by Central Government Departments and their Agencies and institutions such as DST, DBT, DAE, DOs, DRDO, MHRD, ICAR, ICMR, IISc, IISCR etc.+2yrs of Research Exp. <p>Preferable Experience: Expertise in NanoScience, Nanotechnology, Nanobiology, Nanoelectronics and hands-on-experience in Nanofabrication and characterization (such as AFM, SEM, TEM, XRD, Electro-Spinning Device, Materials Printing System, Laser Micromachining, Wire Bonding, Double Sided Mask Aligner,</p>

								Thermal/E-Beam Evaporation, RF Magnetron Sputtering Unit, Oxidation/Diffusion Furnaces, Reactive Ion Etching, FESEM-EBL, Mask Writer, Raman, IR.
2	Project Engineer	01	47000	Rs. 8460.00	Rs. 1250.00	Rs. 56710.00	11	<p>PhD degree Or Master`s degree in Engineering + 3 yrs exp. Or Bachelor`s degree in Engineering + 6 yrs exp.</p> <p>Preferable Experience: Expertise in NanoScience, Nanotechnology, Nanobiology, Nanoelectronics and hands-on-experience in Nanofabrication and characterization. Training, Operation and Maintenance of AFM, SEM, TEM, XRD, Electro-Spinning Device, Materials Printing System, Laser Micromachining, Wire Bonding, Double Sided Mask Aligner, Thermal/E-Beam Evaporation, RF Magnetron Sputtering Unit, Oxidation/Diffusion Furnaces, Reactive Ion Etching, FESEM-EBL, Mask Writer, Raman, IR</p>
3	Assistant Project Engineer	01	28500	Rs. 5130.00	Rs. 1250.00	Rs. 34880.00	11	<p>Bachelor`s degree in Engineering</p> <p>Preferable Experience: Training, Operation and Maintenance of ODF and Wire Bonder. They will also maintain the Web page for the online applications</p>
4	Associate Project Scientist	01	35000	Rs. 6300.00	Rs. 1250.00	Rs. 42550.00	11	<p>Master`s degree in Science or Bachelor`s degree in Science + 4 yrs exp.</p> <p>Preferable Experience: Expertise in Nanoscience, Nanotechnology, Nano biology, Nano electronics and hands-on-experience in Nanofabrication and characterization. Training, Operation and Maintenance of AFM, SEM, TEM, XRD, Electro-Spinning Device, Materials Printing System, Laser Micromachining, Wire Bonding, Double Sided Mask Aligner, Thermal/E-Beam Evaporation, RF Magnetron Sputtering Unit,</p>

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How to apply and selection process: Candidates have to appear in the walk-in-interview at 10:00 AM on 31st July 2024 (Wednesday). They have to send advance copy of their CV mentioning all educational qualifications, experience etc. to nano_off@iitg.ac.in within 29.07.2024 (5PM).

Selection will be based on the performance of the candidate in the interview. Candidates will not be sent any call letter separately.

For any clarification, contact: Nano Office, Centre for Nanotechnology, IIT Guwahati

Email: nano_off@iitg.ac.in

Phone: 0361 2583066

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Assistant Registrar (R&D)